



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

YAMADA, H. et al.

Atty. Ref.: 2635-29; Confirmation No. 4240

Appl. No. 09/960,736

Group: 3729

Filed: September 24, 2001

Examiner: D. Nguyen

For: MANUFACTURING METHOD OF GAS SENSOR AND MANUFACTURING MACHINE
THEREFOR

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April 30, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT UNDER RULE 116

Responsive to the Official Action dated January 30, 2004, kindly enter the
following amendment and remarks.

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MAY 05 2004
TECHNOLOGY CENTER R3700